

Search Notes

Application/Control No.

10/809,203

Examiner

Su C. Kim

Applicant(s)/Patent under
Reexamination

HIRAI, TOSHIMITSU

Art Unit

2823

SEARCHED

| Class | Subclass | Date | Examiner |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
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| updated text search (See search histpry printout) | 12/26/2006 | SK |
| updated text search (See search histpry printout) | 12/26/2006 | SK |
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